

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
)	
Koji Naniwada)	Group Art Unit: 4177
Application No. 10/565,222)	Examiner: Eric R. Hamill
)	
Filed: January 20, 2005)	
)	
For: MEMS TYPE RESONATOR, PROCESS FOR)	
FABRICATING THE SAME AND)	
COMMUNICATION UNIT)	

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO JUNE 16, 2008 OFFICE ACTION

Dear Sir:

This Response is submitted in reply to the Office Action mailed June 16, 2008.
Applicant respectfully requests reconsideration of the application in view of the Amendment and
Remarks herein.